

IAP6 Rec'd PCT/PTO 27 JAN 2006 T

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Ryouichi KOGA et al.

Group Art Unit : Not Yet Assigned

Appl. No. : 10/554,624

(U.S. National Stage of PCT/JP2004/097125)

I.A. Filed : April 27, 2004

Examiner : Not Yet Assigned

For : NOZZLE DEVICE AND HYGIENIC WASHING DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop AMENDMENT
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir :

In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and §§1.97-1.98, Applicants hereby bring the following information to the attention of the Examiner in charge of the above-identified application, which includes information cited and discussed in the specification and the International Search Report issued in connection with International Patent Application No. PCT/JP2004/006066, of which the present application is the U.S. National Stage Application. A copy of the International Search Report was enclosed with the papers when entering the U.S. National Stage on October 27, 2005, and a copy of which is also attached hereto. The Examiner is invited to review these materials to inspect the relevance indicated during international examination with respect to the documents cited therein.

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The following is a list of the documents cited in the above-noted documents:

The relevance of the documents cited in the International Search Report to the claims of the International Application is indicated by the Examiner in the International Search Report.

Japanese Laid-Open Patent Publication No. HEI 11-193567, together with an English language Abstract of the same. Applicants note that this document was cited and discussed on page 1 of the specification of the present application;

Japanese Laid-Open Patent Publication No. 2003-13481, together with an English language Abstract of the same. Applicants note that this document was cited and discussed on page 2 of the specification of the present application;

Japanese Laid-Open Patent Publication No. 2001-90155, together with an English language Abstract of the same and patent family members Japanese Patent No. 3292185 and U.S. Patent No. 6,754,912. Applicants note that this document was cited and discussed on page 3 of the specification of the present application;

Japanese Laid-Open Patent Publication No. SHO 57-172048, together with an English language partial translation of the same;

Japanese Laid-Open Patent Publication No. 2003-119869, together with an English Language partial translation thereof and an English language Abstract thereof;

Japanese Laid-open Patent Publication No. 2001-348940, together with an English language Abstract and an English language partial translation of the same;

Japanese Laid-Open Patent Publication No. HEI 10-90078, together with an English language Abstract and an English language partial translation of the same;

Japanese Laid-Open Utility Model Registration No. HEI 4-73078, together with an English language partial translation of the same;

Japanese Laid-Open Utility Model Registration No. HEI 1-180573, together with an English language partial translation of the same;

Japanese Laid-Open Patent Publication No. 2000-96679, together with an English language Abstract and an English language partial translation of the same; and

Japanese Laid-Open Patent Publication No. 2000-333884, together with an English language Abstract and an English language partial translation of the same.

Further, Applicants call to the Examiner's attention the following documents:

Japanese Patent No. 2995932, together with an English language abstract of patent family member Japanese Laid-open Patent Publication No. HEI 5-33378;

Japanese Laid-Open Patent Publication No. 2001-355272, together with an English language Abstract of the same;

Japanese Laid-Open Patent Publication No. 2002-275996, together with an English language Abstract of the same;

Japanese Laid-Open Patent Publication No. 2001-132055, together with an English language Abstract of the same;

Japanese Laid-Open Patent Publication No. HEI 8-49279, together with an English language Abstract of the same;

Japanese Laid-Open Patent Publication No. HEI 7-292746, together with an English language Abstract of the same;

Japanese Laid-Open Patent Publication No. HEI 8-284236, together with an English language Abstract of the same;

Japanese Laid-Open Patent Publication No. HEI 8-326126, together with an English language Abstract of the same;

Japanese Laid-Open Patent Publication No. HEI 8-49277, together with an English language Abstract of the same;

U.S. Patent Application Publication No. 2003/0140407; and

U.S. Patent Application Publication No. 2005/0246828.

Further to 37 C.F.R. §1.98 (a)(2)(ii), copies of the U.S. patent application publications are not enclosed herewith. However, if copies are needed, the Examiner is respectfully requested to contact the undersigned.

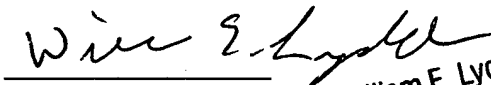
Applicants respectfully request that the Examiner consider the above material and cite the same. Copies of the above-noted foreign documents are attached hereto and all of the above-noted documents are listed on the attached PTO-1449 Form. The Examiner is requested to initial the appropriate spaces on

the attached Form and to return a copy of the completed Form to Applicants with the next official communication in the present application.

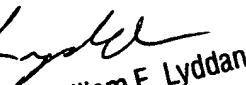
Applicants note that an Office Action on the merits has not issued in the present application, and thus no fee is believed necessary to ensure consideration of the submitted material.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Ryouichi KOGA et al



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FORM PTO-1449

U.S. Department of Commerce
Patent and Trademark OfficeAtty. Docket No.
P28729Application No.
10/554,624INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

(Use several sheets if necessary)

Applicant
R. KOGA et al.Filing Date
April 27, 2004Group
Not Yet Assigned

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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| | | 6 7 5 4 9 1 2 | 06/29/04 | HAYASHI et al. | | | |
| | 2003 | / 1 4 0 4 0 7 | 07/31/03 | MATSUMOTO et al. | | | |
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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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| 1 | English Language Abstract of JP11-193567. |
| 2 | English Language Abstract of JP2003-13481. |
| 3 | English Language Abstract of JP2001-90155. |
| 4 | English Language Abstract of JP3292185. |
| 5 | English Language Abstract of JP2003-119869. |
| 6 | English Language Abstract of 2001-348940. |
| 7 | English Language Abstract of JP10-90078. |
| 8 | English Language Abstract of JP2000-96079. |
| 9 | English Language Abstract of JP2000-333884. |
| 10 | English Language Abstract of JP5-33378. |
| 11 | English Language Abstract of JP2001-355272 |

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

